

**Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only**



EFS ID: 66044

Application ID: 10710821 *10710821*

Title of Invention: ISOLATED FULLY DEPLETED
SILICON-ON-INSULATOR REGIONS
BY SELECTIVE ETCH

First Named Inventor: Matthew Breitwisch

Domestic/Foreign Application: Domestic Application

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Deposit Account Name: William D. Sabo

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